

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Lu et al.

Art Unit: 2826

Serial No.: 10/722,013

Examiner: Erdem, F.

Filing Date: 11/25/2003

Docket No.: TI-35669

Customer No.: 23494

Conf. No.: 6979

Title: A CAPACITOR FORMED ON A RECRYSTALLIZED POLYSILICON LAYER
AND A METHOD OF MANUFACTURE THEREFOR

AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated May 7, 2007. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no **Amendments to the Specification**.

Amendments to the Claims are reflected in the listing of claims that begin on page 2 of this paper.

There are no **Amendments to the Drawings**.

The **Remarks** begin on page 7.